



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/699,897
Filing Date October 27, 2000
Inventor..... Mathew S. Cooper
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1753
Examiner R. McDonald
Attorney's Docket No. H0001190 (4016)
Title: Physical Vapor Deposition Components and Methods of Formation

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10.11.03
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RESPONSE TO FEBRUARY 10, 2003 OFFICE ACTION

To: Commissioner for Patents
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AMENDMENTS

Introductory Comments

The present Response is submitted in the Revised Amendment Format and therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

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